

<b>Notice of References Cited</b>	Application/Control No. 10/711,177	Applicant(s)/Patent Under Reexamination CHIANG ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2001/0008470	07-2001	Dewald, Duane Scott	359/850
	B	US-6,739,723	05-2004	Haven et al.	353/20
	C	US-6,795,243	09-2004	McGettigan et al.	359/486
	D	US-6,927,910	08-2005	Kang, Ho Joong	359/485
	E	US-5,223,975	06-1993	Naganuma et al.	359/487
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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